




**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: /  
Yang Chin Cheng / Group Art Unit:  
/   
Serial No: 10/713,762 /   
/   
Filed: November 13, 2003 / Examiner: unknown  
/   
For: METHODS FOR USING A SILYLATION /   
TECHNIQUE TO REDUCE CELL PITCH /   
IN SEMICONDUCTOR DEVICES /

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service, First Class mail, postage prepaid, in an envelope addressed to Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 18, 2004.  
STOUT, UXA, BUYAN & MULLINS, LLP

  
Kenton R. Mullins, Reg. No. 36,331

**INFORMATION DISCLOSURE STATEMENT**

Sir:

In accordance with 37 C.F.R. 1.56 and 1.97, Applicants wish to call the attention of the Examiner to the references that are listed on the attached PTO form 1449, copies of which are submitted herewith.

Applicant respectfully requests that the cited references be listed on the face of any patent issuing from this application.

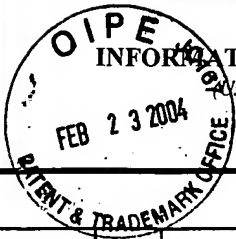
These citations do not constitute an admission that the references are relevant or material to the claims, but rather only constitute the closest art of which Applicants are presently aware.

Respectfully Submitted



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February 18, 2004  
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## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

MXIC-P910284

Application Number

10/713,762

Applicant(s)

Yang Chin Cheng

Filing Date

11/13/03

Group Art Unit

unknown

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,001,739	12/14/1999	Konishi			
		6,316,168	11/13/2001	Butt et al.			

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.